



Docket No.: 52352-372

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Jeffrey A. SHIELDS, et al. :
Serial No.: 09/498,336 : Group Art Unit: 1765
Filed: February 04, 2000 : Examiner: V. Perez-Ramos
For: CF4 + H2O PLASMA ASHING FOR REDUCTION OF CONTACT/VIA
RESISTANCE

AMENDMENT

Commissioner for Patents
Washington, DC 20231

Sir:

The following Amendment and Remarks are submitted in response to the Office
Action dated June 16, 2002.

IN THE SPECIFICATION:

Page 1, please amend the first full paragraph under the caption "RELATED
APPLICATION" as follows:

This application contains subject matter similar to subject matter disclosed in
copending U.S. Patent Application Serial No. [] 09/498,335 filed on
February 4, 2000 [] (Our Docket No. 52352-371)].

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